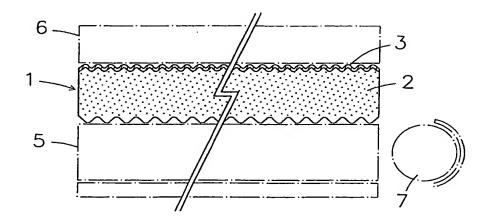
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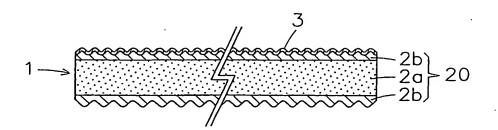
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Fig. 1 第1 図



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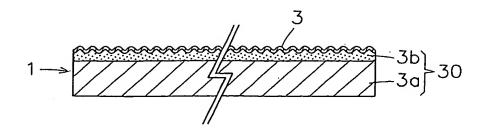
Fig. 2 第2 図



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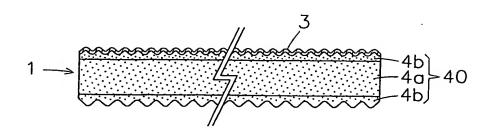
Fig. 3 第 3 図



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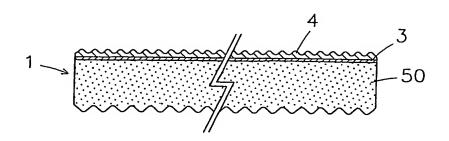
Fig. 4 第 4 図



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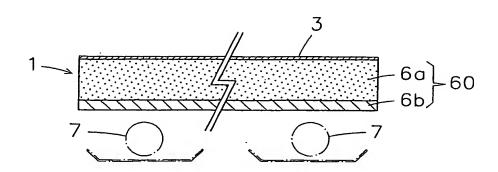
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Fig. 5 第5回



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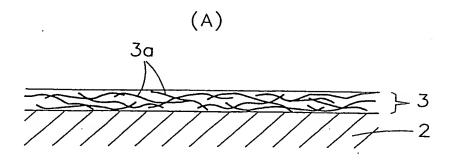
Fig. 6 第 6 図

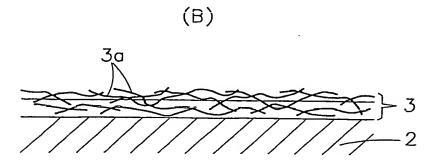


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Fig. 7 第7図





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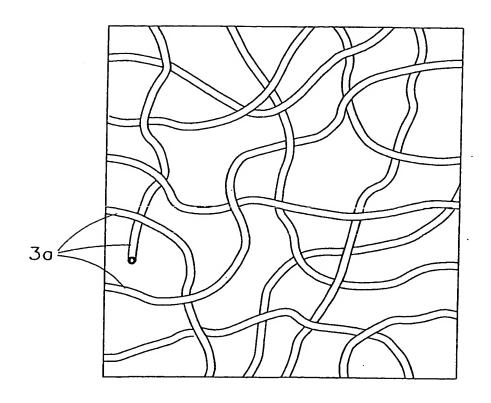
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Fig. 8 第8図



100nm

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Fig. 9 第9 図

